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PATENT

Docket No.: 6217/Consilium/DV

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Nicholas A. WARD et al.

Serial No. 09/927,444

Filed: August 13, 2001

DEC 2 0 2001 E

Group Art Unit: 2812

Examiner:

For: DYNAMIC CONTROL OF WAFER PROCESSING PATHS IN SEMICONDUCTOR

MANUFACTURING PROCESSES

PETITION FOR EXTENSION OF TIME

Honorable Commissioner for Patents Washington, D. C. 20231

Sir:

Applicant petitions the Commissioner of Patents and Trademarks to extend the time for response to the Notice to File Missing Parts of Nonprovisional Application dated September 21, 2001 for one month, from November 21, 2001 to December 21, 2001.

Please charge the \$110.00 fee to cover the cost of the extension to Deposit Account No. 08-0219. Any deficiency or overpayment should be charged or credited to Deposit Account No. 08-0219.

Respectfully submitted,

HALE AND DORR LLP

Anthony H. Kahng

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The Willard Office Building 1455 Pennsylvania Avenue, NW Washington, DC 20004 202 942 8477 SMA:AHK:lrr

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